



Attorney Docket # 5367-47

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Stefan Bader et al.

Serial No.: 10/696,882

Filed: October 30, 2003

For: **METHOD FOR DEPOSITING A
MATERIAL ON A SUBSTRATE
WAFER**

Examiner: G. Nagesh Rao
Group Art: 1722

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Name of applicant, assignee, or Registered Representative

Thomas Langer
Signature

October 24, 2006
Date of Signature

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AMENDMENT AND RESPONSE PURSUANT TO 37 C.F.R. § 1.116

Sir:

This is a response to the Final Office Action dated July 24, 2006. No new matter has been added.

Remarks/Arguments begin on page 5 of this paper.